

# LCLS-II

## LCLS-II Linear Accelerator Cool-Down And Pump-Down

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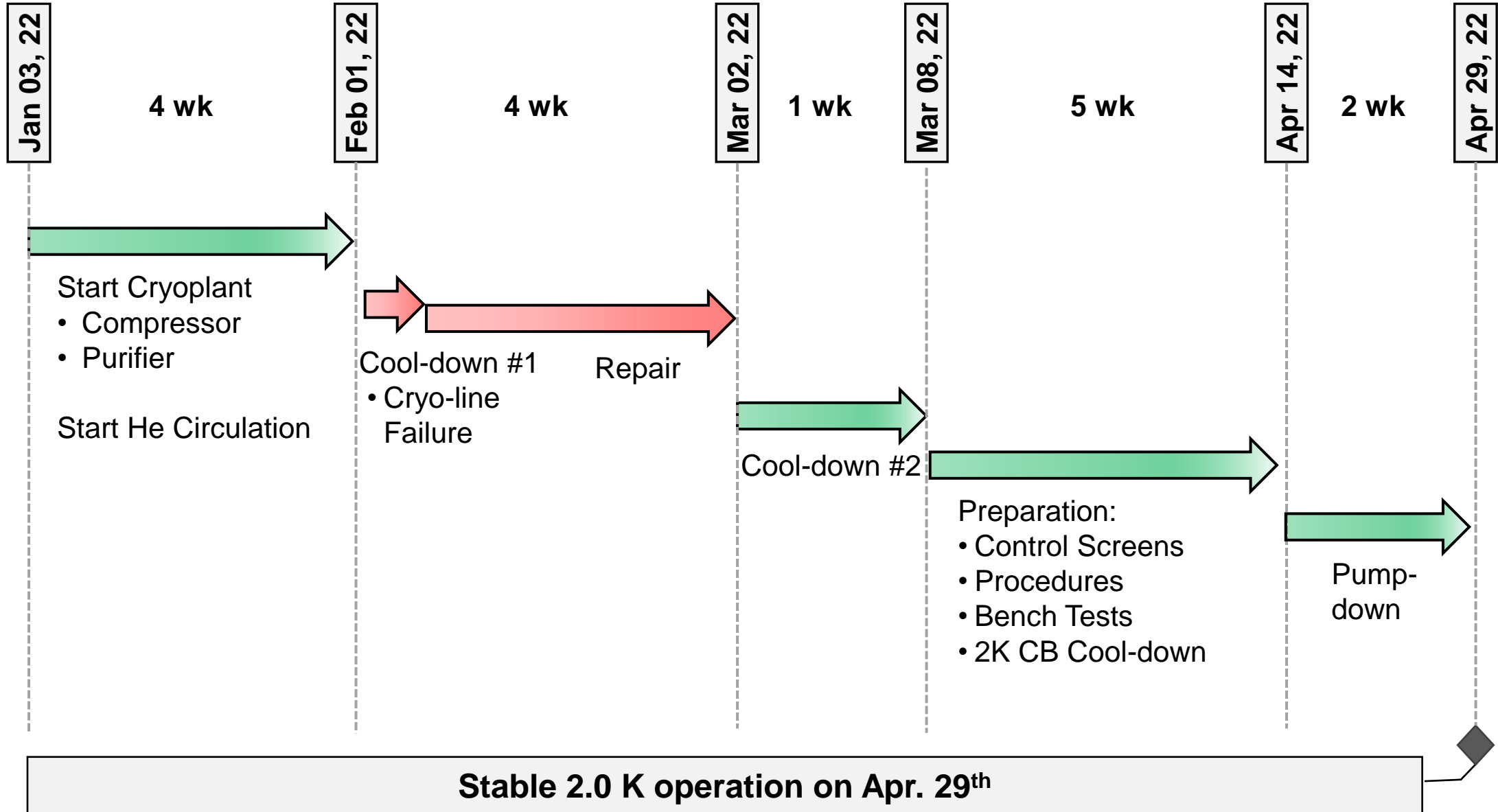
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LCLS-II Process Group Leader

CEC-ICMC23

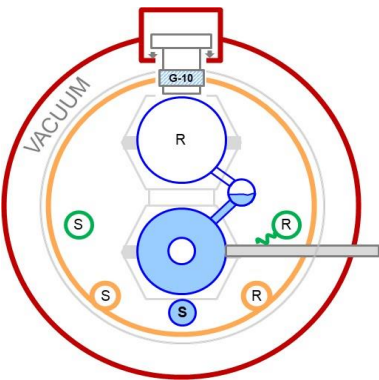
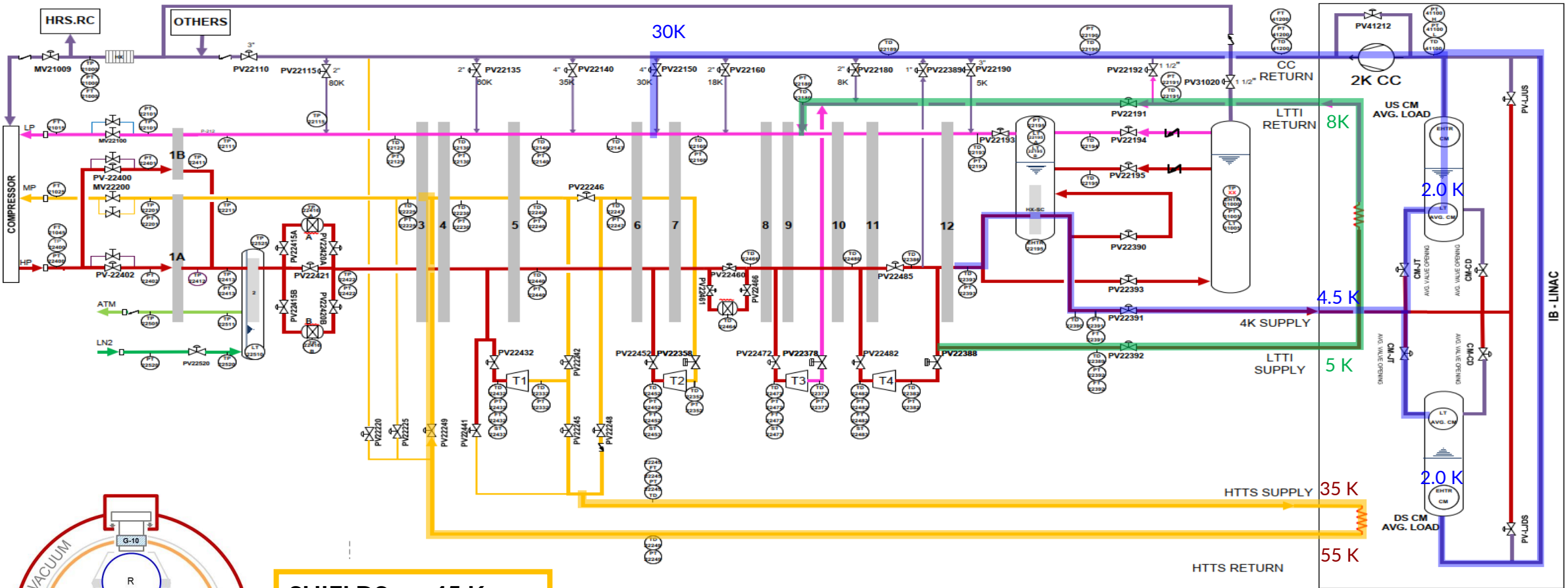
# Outline

- Overview
  - Timeline: Cool-down and Pump-down
- Cool-Down (4.5 K)
  - Scope
  - Strategy
  - Results
  - Challenges
- Pump-Down (2.0 K)
  - Scope
  - Strategy
  - Results
- Summary

# Timeline: Cool-Down and Pump-Down



# Scope: 4K System

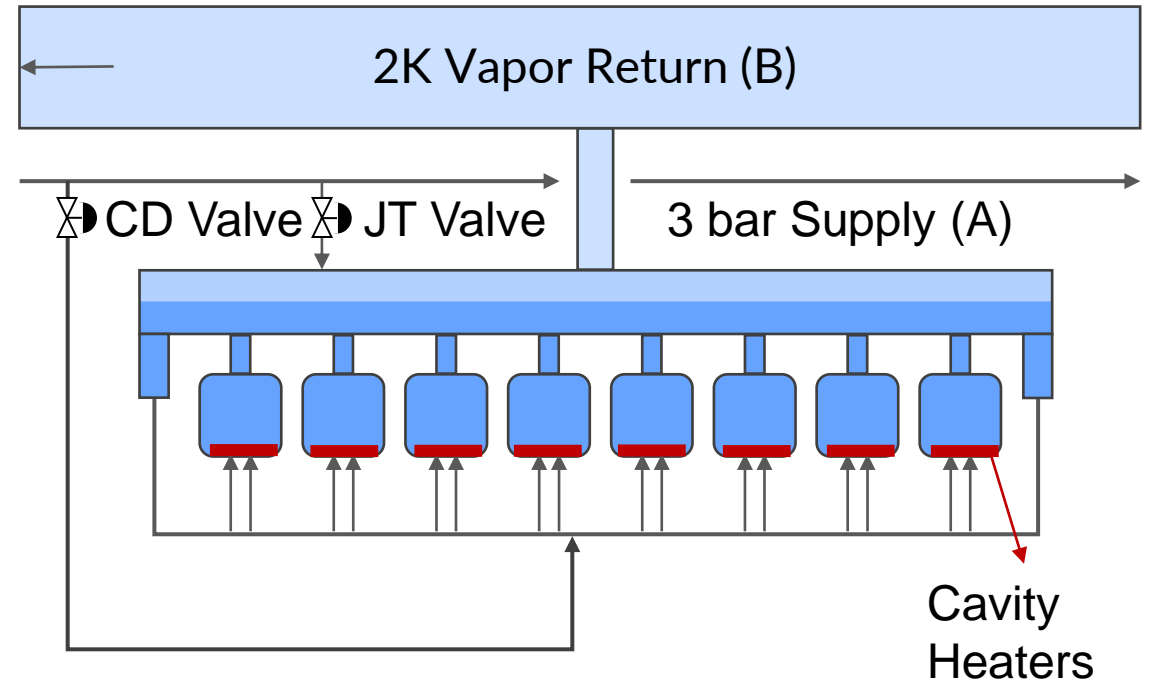
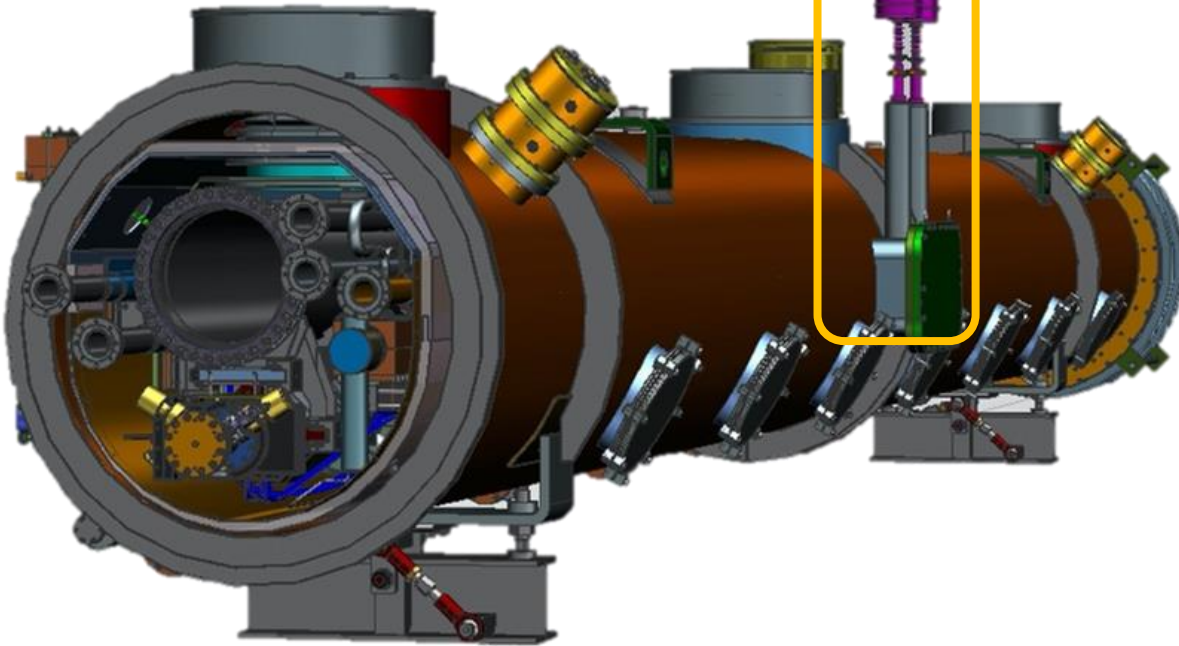


- SHIELDS: 45 K**
- INTERCEPT: 5 K**
- CAVITIES: 2 K**

- Simultaneous cool-down of Cryoplant and LINAC
- Adequate cryoplant cooling capacity:
  - Cavities flow: 100 g/s
  - Shield flow: 100 g/s
  - Intercept: 30 g/s
  - Cool-down time: 1 week

# Scope: Cryomodules

## Cool-Down & JT Valves



	Function	Quantity
CD Valves	<ul style="list-style-type: none"> <li>Supplies helium to the bottom of the cryomodule</li> <li>Used for cryomodule cool-down</li> </ul>	37
JT Valves	<ul style="list-style-type: none"> <li>Supplies helium to the 2-phase pipe</li> <li>Used for maintaining cryomodule liquid level</li> </ul>	37
Cavity Heaters	<ul style="list-style-type: none"> <li>Installed on cavity helium vessel</li> <li>Used for Pressure Regulation @ 2.0K</li> </ul>	296

# Cool-Down: Strategy – HMI Screens

**D1 JT VALVE CONTROL**

GLOBAL CONTROL

SET MANUAL OUTPUT 0.00

SET SEQ OUTPUT 40.00

SET AUTO SP 90.00

SET MAX OUTPUT 70.00

SET MIN OUTPUT 5.00

Output (%)

Readback (%)

D1-PVJT-CM01	D1-PVJT-CM02	D1-PVJT-CM03
Auto	Auto	Auto
MANUAL <input type="checkbox"/>	MANUAL <input type="checkbox"/>	MANUAL <input type="checkbox"/>
55.14	54.89	45.90
SEQUENCER <input type="checkbox"/>	SEQUENCER <input type="checkbox"/>	SEQUENCER <input type="checkbox"/>
45.00	45.00	45.00
AUTO <input checked="" type="checkbox"/>	AUTO <input checked="" type="checkbox"/>	AUTO <input checked="" type="checkbox"/>
92.00	92.00	92.00
70.00	70.00	70.00
5.00	5.00	5.00
54.97	54.90	45.90
54.98	55.02	45.54
Faceplate	Faceplate	Faceplate

x37 CM

**D1 CAVITY HEATER CONTROL**

D1-EHCV-CM01	D1-EHCV-CM02	D1-EHCV-CM03
Sequencer	Sequencer	Sequencer
MANUAL <input type="checkbox"/>	MANUAL <input type="checkbox"/>	MANUAL <input type="checkbox"/>
86.57	86.57	86.57
SEQUENCER <input checked="" type="checkbox"/>	SEQUENCER <input checked="" type="checkbox"/>	SEQUENCER <input checked="" type="checkbox"/>
86.37	86.37	86.37
86.37	86.37	86.37
86.11	86.02	85.74
0.00	0.00	0.00
86.11	86.02	85.74
Faceplate	Faceplate	Faceplate

Manual Output (W)

Sequencer Output (W)

Output (W)

Heater Readback (W)

RF Readback (W)

RF + HTR Readback (W)

x37 CM

**D1 CD VALVE CONTROL**

GLOBAL CONTROL

SET MANUAL OUTPUT 0.00

SET SEQ OUTPUT 0.00

SET AUTO SP 0.00

SET MAX OUTPUT 70.00

SET MIN OUTPUT 40.00

Output (%)

Readback (%)

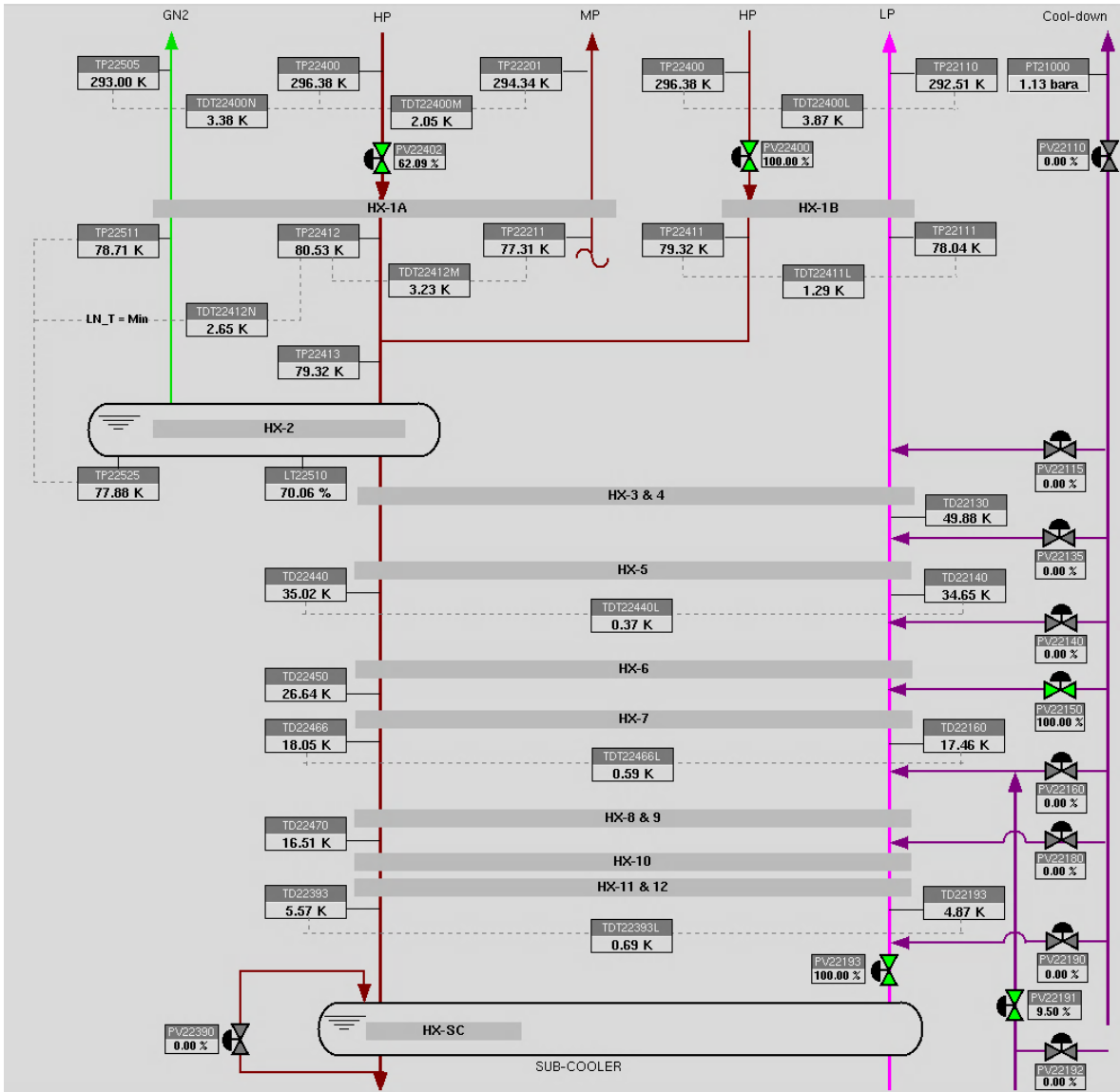
D1-PVCD-CM01	D1-PVCD-CM02	D1-PVCD-CM03
Sequencer	Sequencer	Sequencer
MANUAL <input type="checkbox"/>	MANUAL <input type="checkbox"/>	MANUAL <input type="checkbox"/>
0.00	0.00	0.00
SEQUENCER <input checked="" type="checkbox"/>	SEQUENCER <input checked="" type="checkbox"/>	SEQUENCER <input checked="" type="checkbox"/>
0.00	0.00	0.00
AUTO <input type="checkbox"/>	AUTO <input type="checkbox"/>	AUTO <input type="checkbox"/>
0.00	0.00	0.00
70.00	70.00	70.00
40.00	40.00	40.00
0.00	0.00	0.00
-0.36	0.15	-0.15
Faceplate	Faceplate	Faceplate

x37 CM

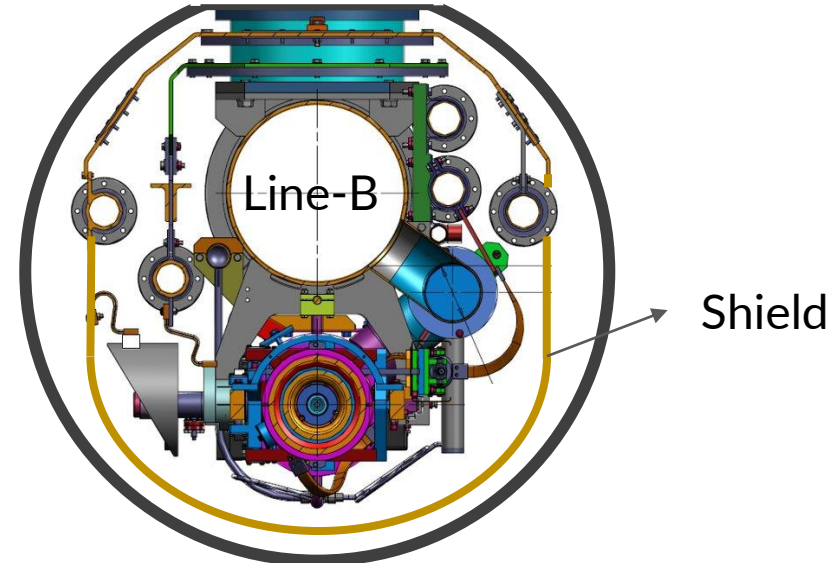
- HMI screen → allows simultaneous control and monitoring of cryomodule valves and heaters



# Cool-Down: Strategy - HMI Screens

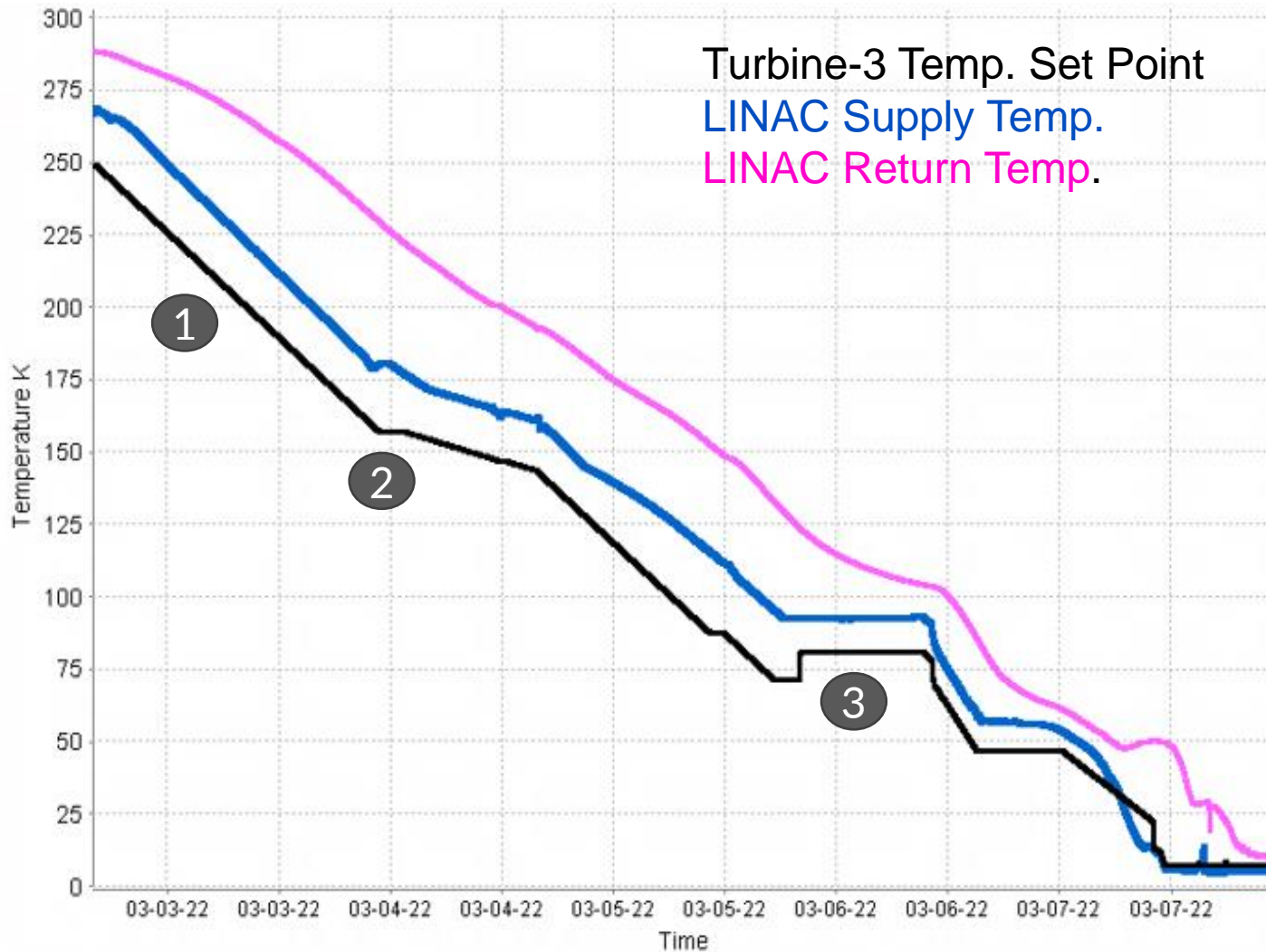


System	Parameters	Spec.
Cryomodule	Line-B Radial DT (within a cryomodule)	< 25 K
	Line-B Long. DT (adjacent cryomodules)	< 70 K
	Shield Long. DT (adjacent cryomodules)	< 70 K
Cryoplant	Brazed Aluminum Heat Exchanger DT	< 50 K



- HMI screens enable monitoring and rapid identification of high DT during LINAC cool-down.

# Cool-Down: Strategy - Automation



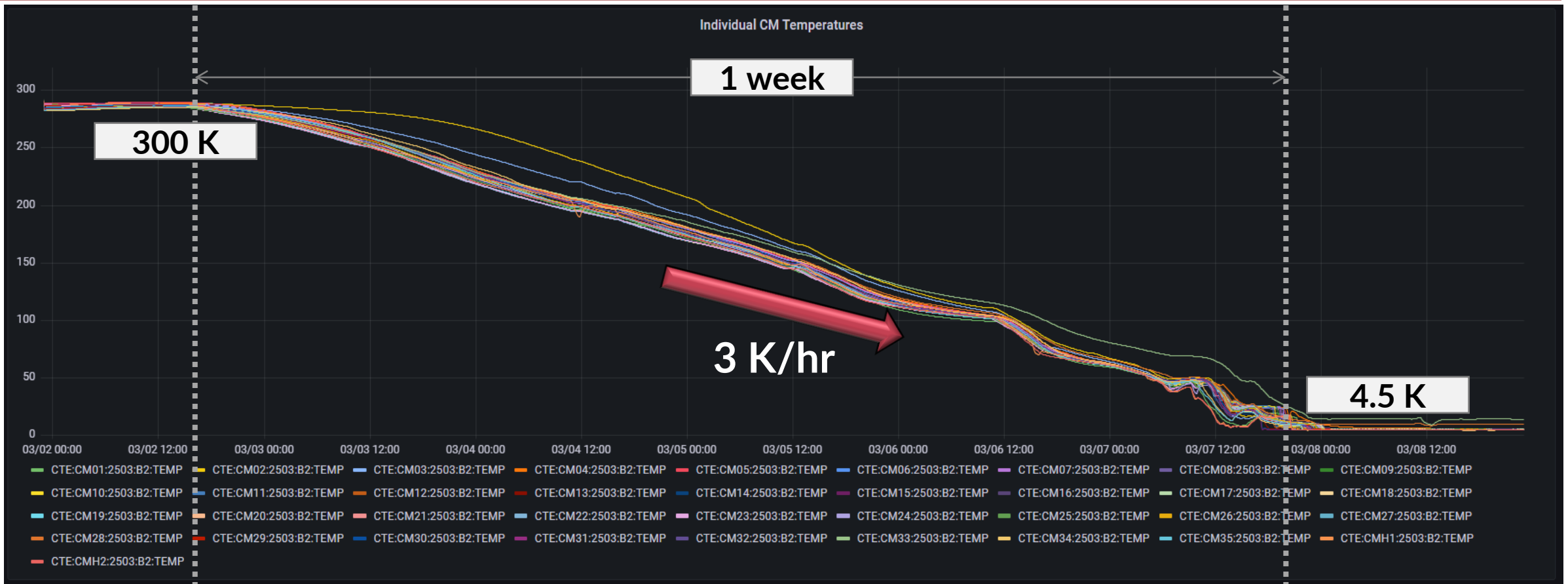
T1, T2 & T3 Cooldown Rate  k/hr

- Cool-down rate → User Specified
- Cool-down Sequence is automated:
  - 1 Turbine Temp. SP is ramped down
  - 2 Turbine Temp. SP is paused if any DT reaches threshold value.
  - 3 Turbine Ramp can be paused for overnight operation

T1, T2 & T3 TIC Ramp:  On  Off

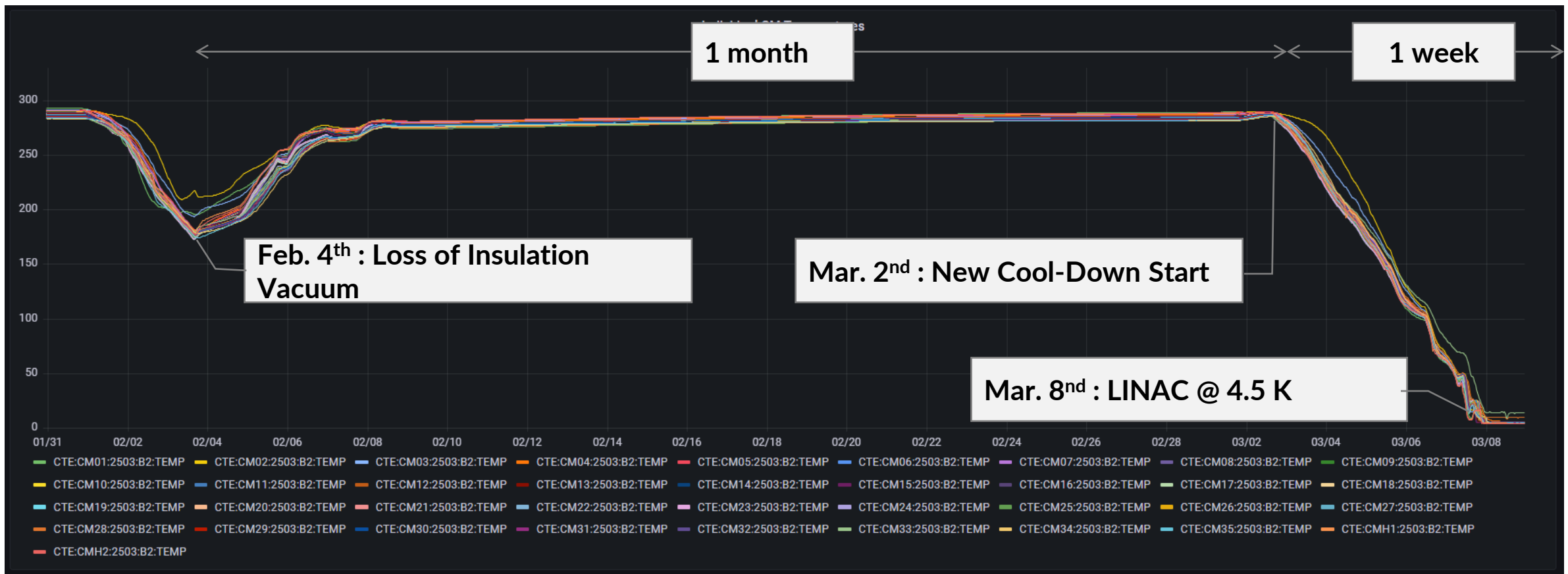


# Cool-Down: Result



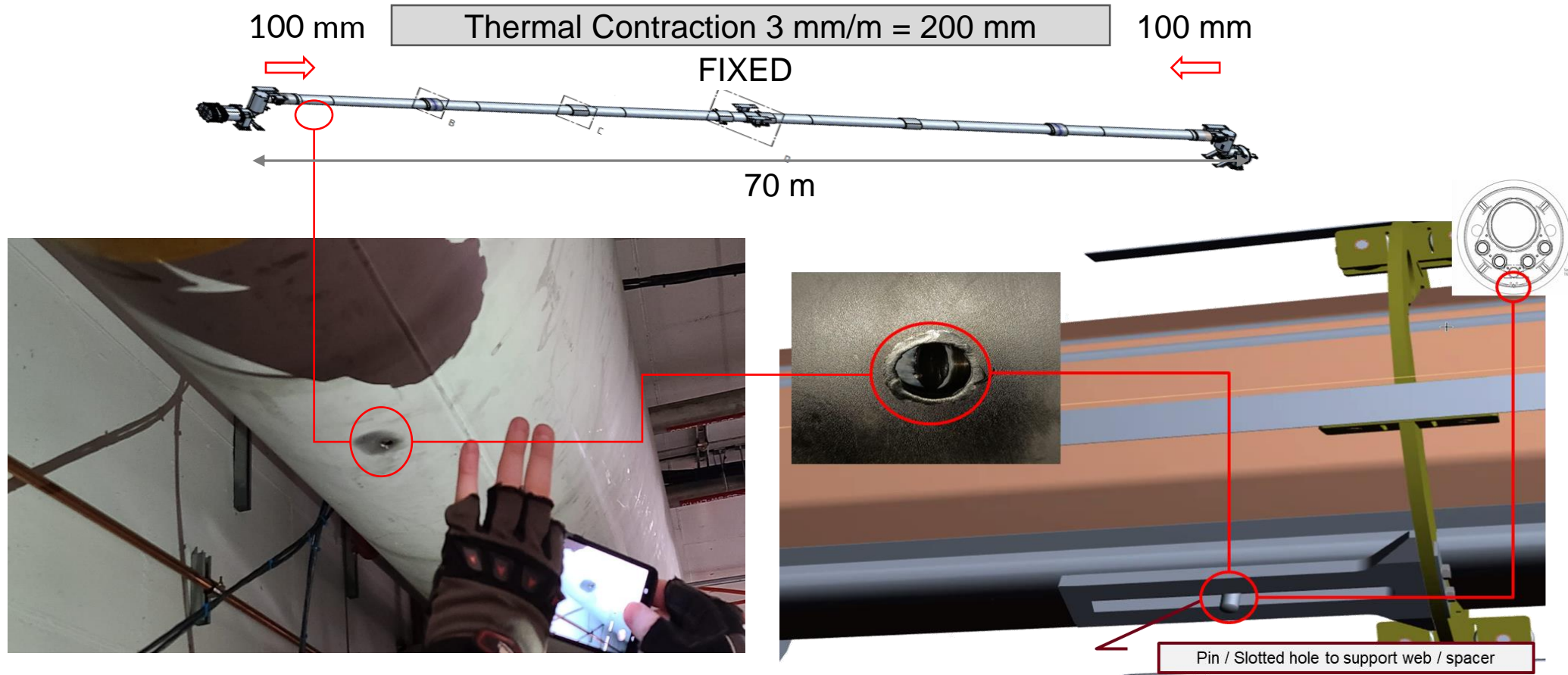
- Successful LINAC cool-down within one week (3K/hr)
- Automation of LINAC cool-down played a pivotal role:
  - Precise temperature control
  - Uniform LINAC and Cryoplant cool-down
  - Safe and efficient operation throughout the cool-down phase

# Cool-Down: Challenges



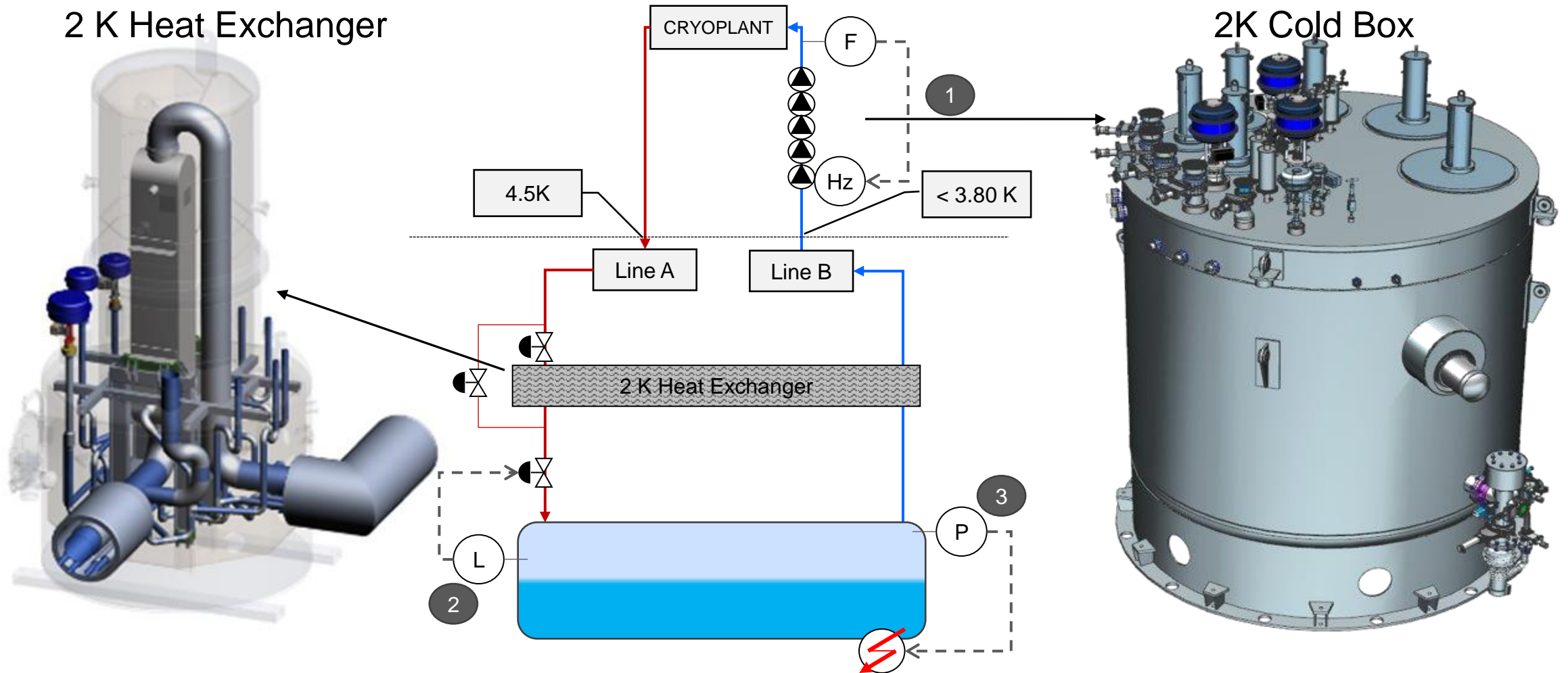
- Loss of insulating vacuum in LINAC cryogenic transfer line during cool-down at ~150 K
- Intense investigation and repair effort: SLAC / Fermilab (FNAL) / DEMACO (vendor)
- Investigation, planning and repair in 1 month
- LINAC cool-down was restarted on Mar. 2<sup>nd</sup> 2022
- LINAC cool-down completed within a week.

# Cool-Down: Challenges



- Linear guide used for blocking rotation of the process pipe bundle → failed.
- Failure caused opening in the vacuum jacket → loss of insulation vacuum.

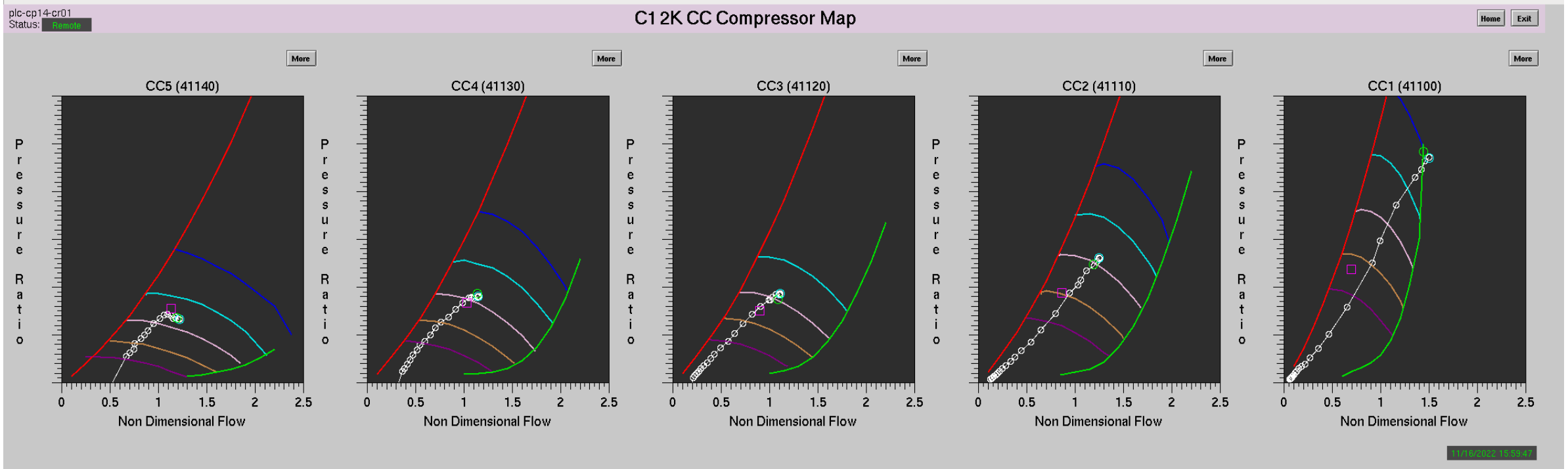
# Pump-Down: Scope



- ① Cold compressor speed control
- ② LINAC heater control
- ③ LINAC JT-valve control

- Compressor Flow
- LINAC Pressure
- Individual Cryomodules Level

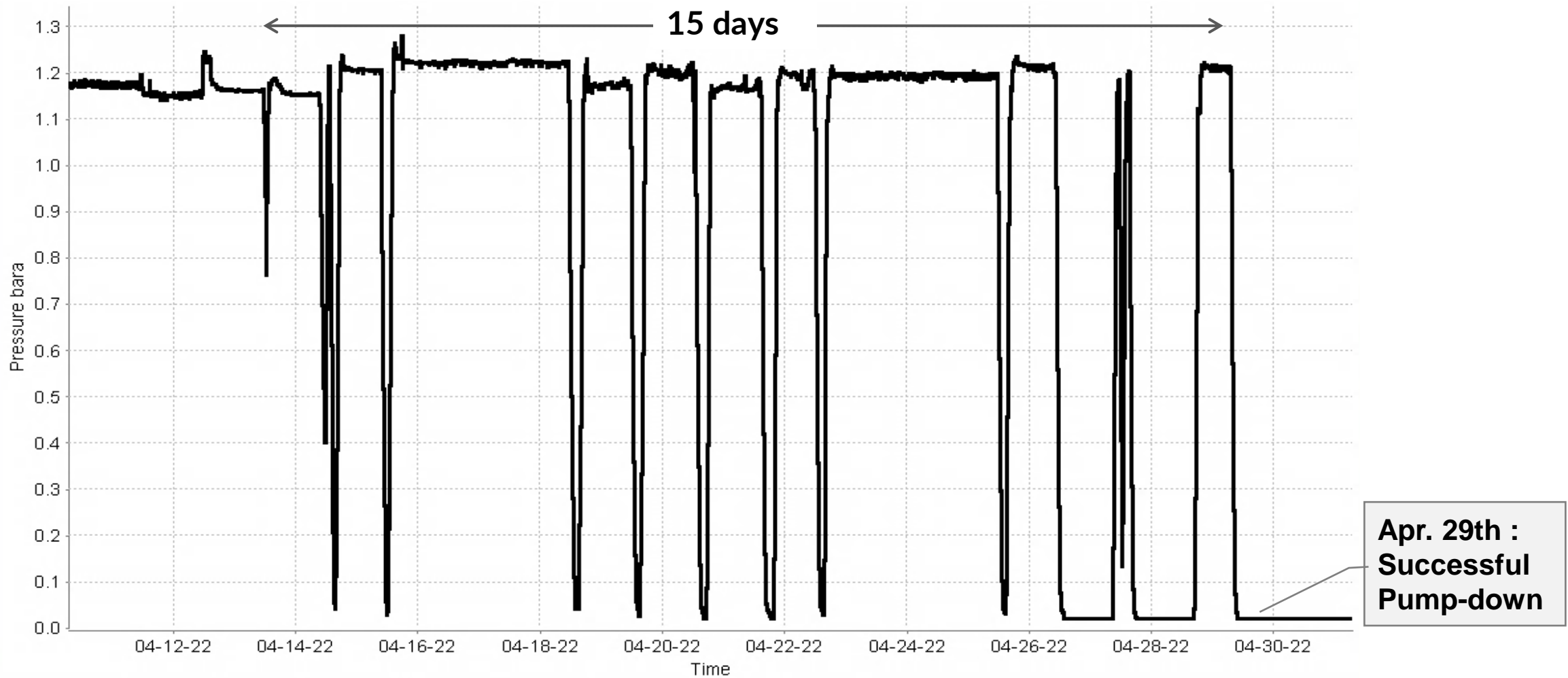
# Pump-Down: Strategy



- Cold Compressor Maps HMI Screens:
  - Real time monitoring of cold compressor performance
  - Critical for detecting issues in relationship to the cold compressor thresholds.
  - Efficient tuning of 2K pump-down parameters.
  
- Pump-down table: Speed vs Suction Pressure
  - Excellent vendor support



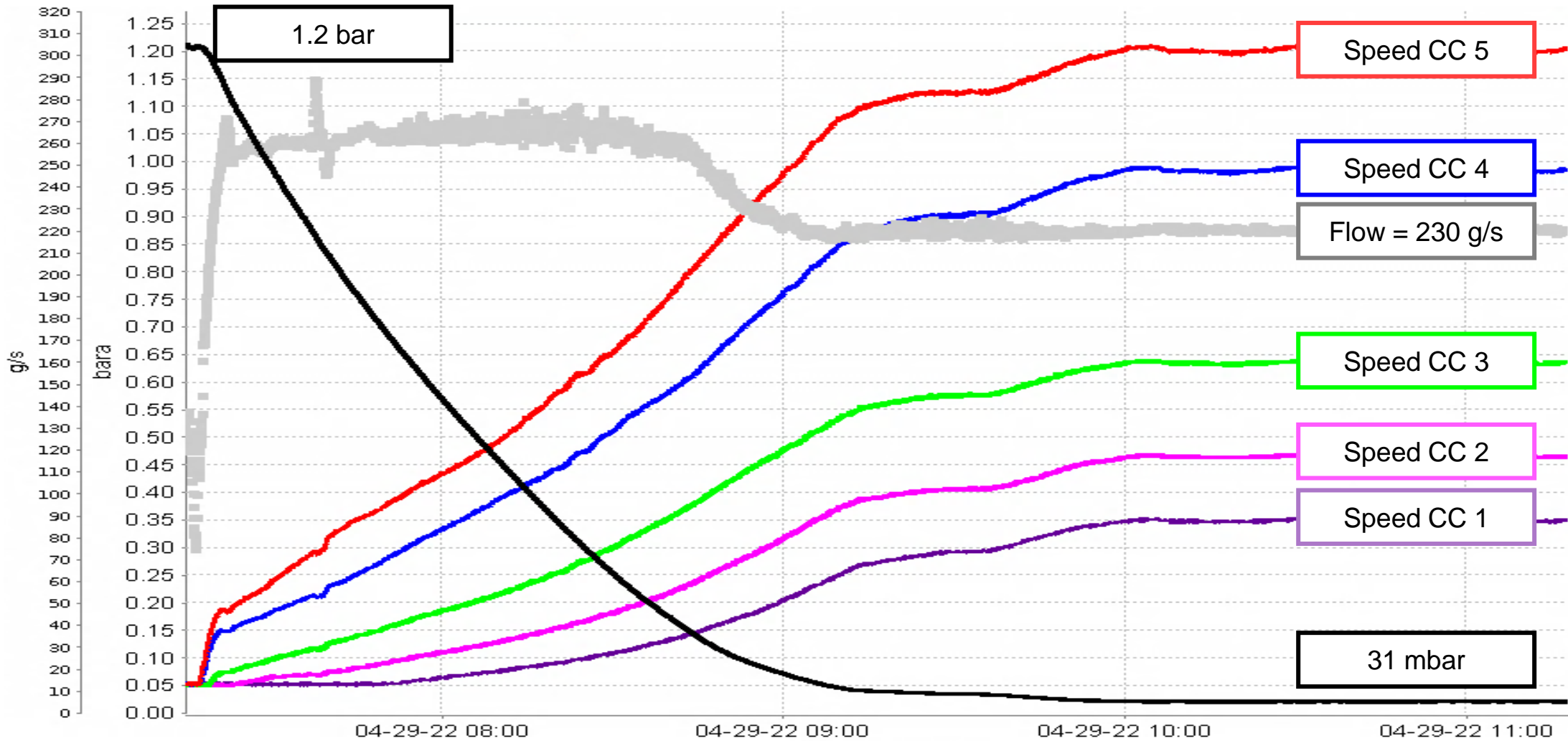
# Pump-Down: Results



- 10 initial attempts : compressor surge, instrumentation, pressure stability
- Stable operation at 2 K was successfully achieved after 15 days



# Pump-Down: Result



- LINAC: Successful PUMP-DOWN: Apr. 29<sup>th</sup>, in 2.5 hours.
- Code Improvements: have reduced duration to 1.5 hr.

# Summary

- Successful LCLS-II LINAC Cool-Down and Pump-Down
- Key aspects for successful commissioning:
  - Detailed documentation describing system behaviour (Functional Analysis)
  - Clear HMI: early detection of issues and improving system response
  - Careful planning supported by thorough Procedures
- LCLS-II cryosystem success was possible thanks to:
  - Vendor: excellent support for commissioning and technical challenges.
  - Strong Technical collaboration with Jefferson Lab
  - Continued discussions with Fermilab, CERN, SNS and BNL.



# Thank you